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LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)					APPLICANT H. Daniel Dulman			
					FILING DATE Feb. 5, 2002 (RCE Filed Herewith)		GROUP 1756	
U.S. PATENT DOCUMENTS								
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
DL	AA	5,629,113	05/97	Watanabe				
	AB	6,007,324	12/99	Tzu et al.				
	AC	5,384,219	01/95	Dao et al.				
	AD	5,300,379	04/94	Dao et al.				
DL	AE	5,897,975	04/99	Ahn et al.				
	AF							
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	AH							
	AI							
	AJ							
	AK							
FOREIGN PATENT DOCUMENTS								
		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
DL	AL	US 03/ 02288	01/03	PCT Search Report				
DL	AM	0 395 425 A2/A3	04/90	EPO				
DL	AN	0 583,942 A2	08/93	EPO				
	AO							
	AP							
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)								
DL	AQ		Cui, Z. et al., "Partial Rim: A New Design of Rim Phase Shift Mask for Submicron Contact Holes", SPIE					
			Vol. 2440, Feb. 1995, pp. 541-549.					
	AR							
	AS							
EXAMINER					DATE CONSIDERED			
[Signature]					3/2/04			
<p>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</p>								